

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: David C. Chu

Serial No.: 10/052,673

Filed: January 17, 2002

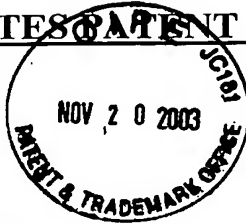
Due Date: November 19, 2003

Title: SYSTEM AND METHOD FOR INTERFEROMETER NON-LINEARITY
COMPENSATION

Examiner: Demetrius R. Pretlow

Group Art Unit: 2863

Docket No.: 10020043-1 (A310.119.101)



AMENDMENT AND RESPONSE

Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir/Madam:

This Amendment is responsive to the Office Action mailed August 19, 2003. Please amend the above-identified patent application as follows:

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DEC - 1 2003
TECHNOLOGY CENTER 2800